



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*In re* application of:  
Yoshihide SENZAKI *et al.*

Serial No. 10/656,628

Filed: September 5, 2003

For: Low Temperature Deposition Of Silicon  
Based Thin Films By Single-Wafer Hot-  
Wall Rapid Thermal Chemical Vapor  
Deposition

Examiner: CHEN, Bret P.

Group Art Unit: 1762

Confirmation No. 8131

Date: June 28, 2006

**RESPONSE/AMENDMENT AFTER FINAL**

**MAIL STOP AMENDMENT AFTER FINAL**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment is in response to the final Office Action dated March 28, 2006. Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.



# TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

<b>Total Number of Pages in This Submission</b>	<b>10</b>	<b>Application No.</b>	<b>10/656,628</b>
		<b>Filing Date</b>	<b>September 5, 2003</b>
		<b>First Named</b>	<b>Yoshihide SENZAKI et al.</b>
		<b>Examiner Name</b>	<b>CHEN, Bret P.M.</b>
		<b>Group Art Unit</b>	<b>1762</b>
		<b>Attorney Docket No.</b>	<b>A-71730/MSS (463035-878)</b>

ENCLOSURES (check all that apply)		
<input type="checkbox"/> Fee Transmittal Form	<input type="checkbox"/> Assignment Papers (for an Application)	<input type="checkbox"/> After Allowance Communication to Group
<input type="checkbox"/> Fee Attached \$0.00	<input type="checkbox"/> Drawing(s) (Informal)-3 pgs	<input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences
<input checked="" type="checkbox"/> Amendment / Reply	<input type="checkbox"/> Licensing-related Papers	<input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)
<input checked="" type="checkbox"/> After Final	<input type="checkbox"/> Petition	<input type="checkbox"/> Proprietary Information
<input type="checkbox"/> Affidavits/declaration(s)	<input type="checkbox"/> Petition to Convert to a Provisional Application	<input type="checkbox"/> Status Letter
<input type="checkbox"/> Extension of Time Request	<input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address	<input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): A self-addressed stamped Postcard.
<input type="checkbox"/> Express Abandonment Request	<input type="checkbox"/> Terminal Disclaimer	
<input type="checkbox"/> Supplemental Information Disclosure Statement (3 pgs.)	<input type="checkbox"/> Request for Refund	
<input type="checkbox"/> Certified Copy of Priority Document(s)	<input type="checkbox"/> CD, No. of CD(s) _____	
<input type="checkbox"/> Response to Missing Parts/ Incomplete Application	Remarks	
<input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53		

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT		
Firm or Individual name	Maria S. Swiatek, Reg. No. 37,244 DORSEY & WHITNEY LLP 555 California Street, Suite 1000 San Francisco, CA 94101 Telephone: (650) 857-1717 Facsimile: (650) 857-1288	Customer Number 32940
Signature	<i>Maria Swiatek</i>	
Date	June 28, 2006	

CERTIFICATE OF MAILING		
I hereby certify that this correspondence is being deposited with the United States Postal Service with Sufficient postage as first class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this date:		
Typed or printed name		06/28/06
Kari B. Aguiar		
Signature	<i>Kari B. Aguiar</i>	Date
		June 28, 2006